

#20/EN-
1/22/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Armbrust et al.

Serial No.: 09/666,325

Group Art Unit: 2811

Filed: September 21, 2000

Examiner: Kang, D.

For: SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED
ADHESION/ELECTROMIGRATIONAssistant Commissioner of Patents
Washington, D.C. 20231**AMENDMENT UNDER 37 C.F.R. §1.116**

Sir:

In response to the Office Action mailed November 18, 2002, please amend the application as follows.

IN THE CLAIMS:

Please substitute the following claims for the same numbered claims in the application.

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|--|--|----------------------------|-------------------------------|-------------------------------------|
| CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8) | | | | Docket No. BU9-98-110 DIV |
| Applicant(s): Armbrust et al. | | | | |
| Serial No. 09/666,325 | Filing Date September 21, 2000 | Examiner D. Kang | Group Art Unit 2811 | |
| Invention: SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED ADHESION/ ELECTROMIGRATION | | | | |
| <p>I hereby certify that this <u>AMENDMENT UNDER 37 CFR 1.116</u> (Identify type of correspondence) is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9319</u>) on <u>1/16/03</u> (Date)</p> <p>Frederick W. Gibb, III (Type or Printed Name of Person Signing Certificate)  (Signature)</p> | | | | |
| <p>FAX RECEIVED Note: Each paper must have its own certificate of mailing.</p> <p>JAN 16 2003</p> <p>TECHNOLOGY CENTER 2800</p> | | | | |